

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Daniel G. Stearns et al.                      Docket No. : CIL-10705B  
Serial No. : 10/631,359                                      Art Unit: 1756  
Filed : July 31, 2003                                      Examiner: S. Mohamedulla  
For : EUV Lithography Reticles Fabricated  
Without The Use Of A Patterned Absorber

**APPLICATION FOR  
CHANGE IN CORRESPONDENCE ADDRESS**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Please change the Correspondence Address for the above-identified  
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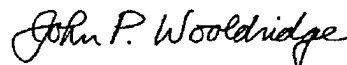
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If you have any questions, please contact the undersigned at 808-875-0012.

Respectfully submitted,



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John P. Wooldridge  
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Dated: September 2, 2004